



Site-selectively grown SnO₂ NWs networks on micromembranes for efficient ammonia sensing in humid conditions



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ABSTRACT

SnO₂ NWs networks on heated micromembranes have been characterized as ammonia sensors. The approach allows achieving reproducible growth and stable and long-lasting ammonia sensors with site-specific grown SnO₂ NWs. The devices have been tested both in dry and humid conditions showing response time down to two minutes. Sensors have been tested up to 1 month, only presenting variation of the base resistance with full retention of the response towards the gaseous analytes. Different concurrent sensing mechanisms have been identified relating the determined sensing kinetics with previous theoretical calculations. Specifically, oxygen dissociation seems to play a key role in the overall ammonia sensing sequence. In humid conditions, moisture reduces the response to ammonia but also lowers the activation energy of the reaction process.

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1. Introduction

Ammonia is a toxic gas with irritant properties that can injure the respiratory tract [1]. Anthropogenic emissions mainly comes in a 95% from agriculture, where ammonium salts are widely used as a fertilizer [2]. On the other hand, swine farms can achieve high concentrations of ammonia up to 100 ppm generated by decomposition of pig manure via metabolic activities of bacteria and fungi [3].

Furthermore, ammonia, together with urea, is used in automotive applications for selective catalytic reduction (SCR) of nitrogen oxide (NO_x) to nitrogen in order to avoid harmful gas emissions in diesel heavy weight engines, which gives also H₂O as a byproduct [4,5]. Accurate measurements of the ammonia concentration for SCR are needed for an efficient process and the recycling of the non-reacted ammonia fraction.

SnO₂ and other metal oxides have been explored as chemoresistive gas sensing materials since the development of Taguchi sensors four decades ago [6]. More recently, nanostructured metal oxide materials were developed in order to improve the sensing

properties by enhancing the surface to volume ratio [7]. Among them, nanowires are one of the most studied and promising structures because of their well-controlled chemical and physical properties [8]. Nanowire-based gas sensors have been developed by using individual structures [9] or in a network form where the electrical current flows through the nanowires along the axial direction [10]. Single SnO₂ nanowire gas sensors have been demonstrated as sensitive and effective devices, but are constrained by *ad hoc* contact fabrication, which is time consuming and difficult to systematize. A possibility for its industrial processing would be the alignment of nanowires using dielectrophoretic forces [11].

Monocrystalline SnO₂ structures offer better stability to gas response than multigrained ones because the former expose more stable, homogeneous and well defined crystal planes to gases. Single crystalline nanowires can be prepared by metal seed supported gas phase growth techniques, such as chemical vapor deposition (CVD) or pulsed laser deposition (PLD) [8]. The growth of nanowires often requires high temperatures; for instance, SnO₂ nanowires form around 700 °C [12]. The growth process according to the vapor-liquid-solid mechanism (VLS) is frequently performed by CVD, involving long times for heating up and cooling down due to the high thermal mass of the furnace; additionally, the entire heated substrate is coated and not only the active area. Consequently, the transfer of nanowires to the final device is required,

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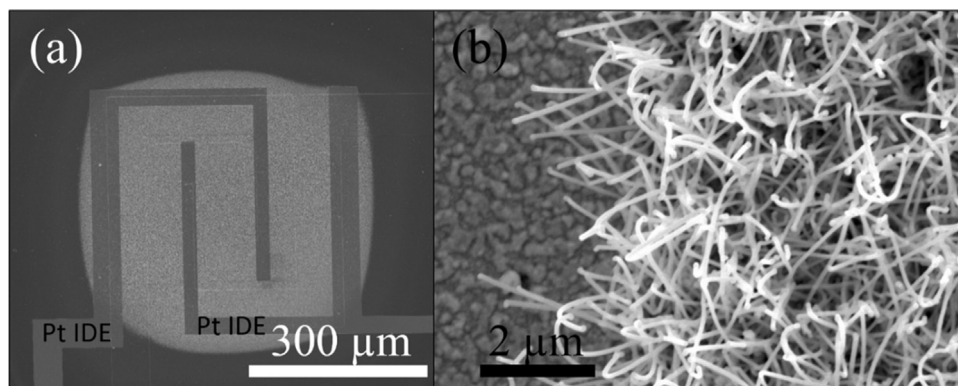


Fig. 1. (a) SEM general view of the micromembrane with Pt interdigitated electrodes (IDE) on the top. Brighter area corresponds to the grown SnO₂ NWs; (b) SEM image of SnO₂ NWs contacting the Pt electrode (on the left side);.

adding complexity to the approach. Precise growth and integration of nanowires in an efficient and reproducible way is one of the most challenging aspects for gas sensors based on such structures.

Thus, nanostructures grown directly on the final electronic device severely reduces fabrication steps and manufacturing cost. At the same time, a low power consumption during the growth is achieved due to the small mass of the heated area allowing fast heating and cooling processes. The approach presented here is based on direct growth of nanowires onto micromembranes, small membrane areas of $400 \times 400 \mu\text{m}$ with an incorporated heater that provides the temperature necessary for the growth of SnO₂ nanowires and for the sensor operation [13]. The nanostructures are available after the growth for resistor-type sensing applications without requiring any additional fabrication step due to the bridging of the interdigitate on top of the heater.

In this work, we present an ammonia sensor based on SnO₂ nanowires grown by this direct integration process of nanostructures with the electronic platform and their response in dry and humid air.

2. Experimental details

Bulk micromachined substrates were used as a platform for the growth of nanowires. Chips consist of 4 isolating micromembranes with a thickness about $1.1 \mu\text{m}$ with reduced thermal mass that provides fast thermal response. Each micromembrane contains a poly-Si doped buried heater embedded in Si₃N₄ with an isolating layer of SiO₂ on the top; Pt interdigitated electrodes are on top of the layers. The details of a very similar platform are described elsewhere [13]. The micromembranes are mounted onto a TO-8 holder, and wire bonded to them.

The synthesis of NWs on top of micromembranes is carried out according to the growth process reported in [14]. A non-continuous Au layer is deposited by 5–10 seconds sputtering and used as a catalyst of the VLS mechanism growth based on the decomposition of the Sn(O^tBu)₄ precursor. In order to carry out the growth, the chip with 4 micromembranes is introduced in a quartz-chamber, where the heaters are externally biased while the gaseous precursor is flowing through the chamber. Synthesis is carried out locally only on the heated membranes where the thermal decomposition of the precursor occurs. Low power consumption is required for the growth: 48 mW are needed to achieve this temperature. Growth of NWs takes 30 min including the heating up and cooling down ramps. SnO₂ NWs are grown in low vacuum conditions at a pressure of 0.1 mbar and at temperature around 700 °C.

The response of SnO₂ NWs was characterized in a home-made stainless steel chamber of 8.6 ml volume connected to a Gometrics MGP2 gas mixer with 4 Bronkhorst Mass-Flow Controllers.

Constant flow of 200 ml/min was kept both for dry and humid air measurements. Water vapor was added by deviating a part of the synthetic air flow through a bubbler. Relative humidity provided by the bubbler was calibrated as a function of the air flow before NWS-based sensor characterization using a commercial humidity sensor at 20 °C. The relative humidity conditions indicated throughout the paper are referenced to the RH at room temperature. Keithley 2602A dual Source Measure Unit allowed to control simultaneously the resistance of the sensor and the voltage for heating the micromembrane. Electrical measurements and flowing gases were controlled by a home-developed Labview software.

SnO₂ NWs based gas sensors were characterized towards ammonia by allowing 5 hours to stabilize the baseline, and then first exposing for 1 h to ammonia. The sensors were then exposed to air for 2 h to recover the baseline. This sequence was repeated for the different ammonia concentrations for both dry and humid characterization.

3. Results and discussion

3.1. Temperature behavior in absence of ammonia and humidity

A low magnification SEM image of a micromembrane, where SnO₂ NWs have grown site-selectively, is presented in Fig. 1(a). The brighter area in this figure denotes the growth of the nanostructures, which also follows the temperature profile provided by the heater. A higher magnification SEM picture of NWs close to the Pt electrode is shown in Fig. 1(b), where no NWs are found on top of it; a Pt/Au alloy formed during annealing has not acted as a catalyst for nanowires growth.

The crystalline structure of tin dioxide NWs has been analyzed by High Resolution Transmission Electron Microscopy (HRTEM), represented in Fig. 1 Fig. 2(a). As reported in a previous work [14], the locally grown SnO₂ nanowires are monocrystalline, with tetragonal (rutile) phase, with predominant [101] growth direction. A cross-section SEM image of a device with slightly shorter nanowires is shown in Fig. 2(b), where a high density of NWs is found with a length between 2 and 5 μm, and the contact between the network of NWs can be observed. Besides, a very thin layer is observed between the nanowires and the SiO₂ layer. The two-dimensional growth occurs simultaneously during the synthesis of the nanowires with a much lower growth rate and leads to a nanocrystalline layer of SnO₂ because it is a non-catalyzed process. The thickness of this layer is between 30 and 80 nm and the layer roughness observed is due to the base of nanowires that remained after the sample preparation.

The behavior of the electrical resistance of SnO₂ NWs at different temperatures in synthetic air atmosphere has been investigated

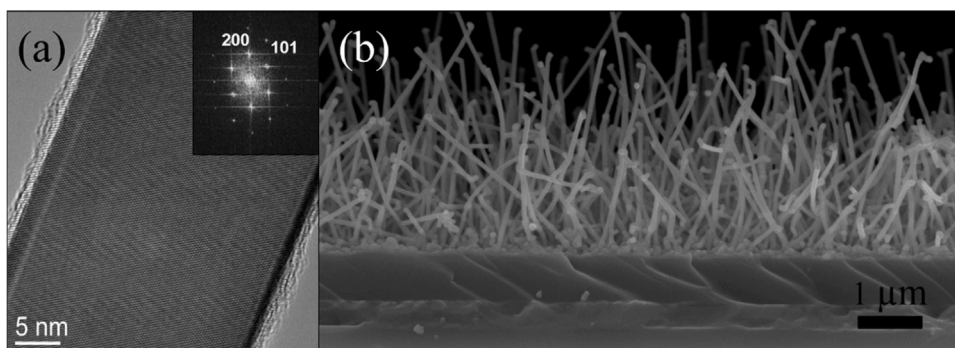


Fig. 2. (a) HR-TEM image of a monocrystalline SnO₂ NW that crystallizes in rutile phase. Inset FFT illustrates the [101] predominant growth direction; (b) Cross-section of SnO₂ NWs-based sensor. A very thin layer is observed below the NWs of a thickness between 30–80 nm.

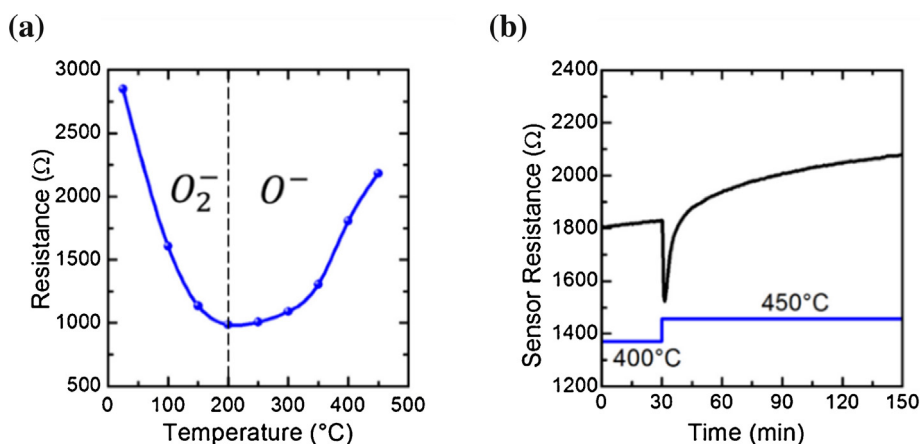


Fig. 3. (a) Resistance of SnO₂ locally grown NWs as a function of temperature. The minimum in resistance reflects the change in the adsorbed oxygen specie; (b) Transient response of the sensor resistance in a change of temperature illustrating the increase in resistance for increasing temperatures above 200 °C. Blue line represents the evolution of temperature.

in order to study the oxygen species that are chemisorbed at the surface of the metal oxide nanostructure (Fig. 3(a)). The resistance of SnO₂ NWs at room temperature is 2850 Ω, and decreases for increasing temperatures up to 200 °C. Above this temperature and up to 450 °C, the maximum studied temperature, the resistance increases. At temperatures above 500 °C, the resistance changes the tendency and decreases for increasing temperatures, which is related to the lower coverage of O⁻ oxygen species. The same temperature behavior has been obtained in other sensors based on SnO₂ [15]. The SnO₂ nanowires present a low resistance, which is probably due to a highly defective surface. I–V curves of the sensor show an ohmic behavior even at room temperature, which remarks the absence of a Pt/SnO₂ Schottky barrier that would be expected for a pure Pt/SnO₂ interface. The interface between the Pt electrodes and the SnO₂ NWs is partially responsible for a lower resistance than if a Schottky barrier would be present.

At low temperatures atmospheric oxygen is physisorbed [15]. This mechanism takes place without electron transfer and therefore, cannot change the resistivity of the semiconductor. During physisorption, the change in resistance observed is purely due to the excitation of charge carriers. Molecular oxygen (O₂⁻) is chemisorbed at the surface at temperatures around 150–200 °C with some degree of charge transfer from the oxide towards the adsorbate. Above 200 °C the oxygen trapped by means of chemisorption can dissociate in two atomic oxygen species (O⁻) according to:



Thus, O⁻ leads to capture more electrons from the semiconductor and thus, increase its resistance [15,16]. The observed resistance behavior has also been reported for other SnO₂ structures at similar temperatures [16]. Therefore, the resistance is related to the particular oxygen species adsorbed at the metal oxide surface. The high temperature range starting at 600 °C renders oxygen atoms that share two electrons (O²⁻) with the metal oxide [15]. However, these high temperatures are beyond the scope of the present work.

Transient response of the SnO₂ NW device resistance with increasing temperature from 400 to 450 °C is represented in Fig. 3(b). The low thermal mass of the micromembranes provides a fast thermal response of the order of tens of microseconds to achieve 200 °C [13] which leads to the initial fast decay in resistance when the temperature is changed, but is afterwards followed by a slower increase. The gradual increase in resistance is related to the chemisorption of atomic oxygen species, since temperature changes induce a new dynamic equilibrium between the wire and the adsorbates.

3.2. Response to ammonia in dry synthetic air

The change in resistance of the locally grown nanowires against ammonia in synthetic air has been measured. The concentration of ammonia has been varied between 10 and 40 ppm, which is in the range of time-weighted average exposure limit recommended by NIOSH (25 ppm) for up-to 10 h workday [17]. The evolution of the sensor resistance at different temperatures is represented in Fig. 4(a), where the decrease in resistance in the presence of

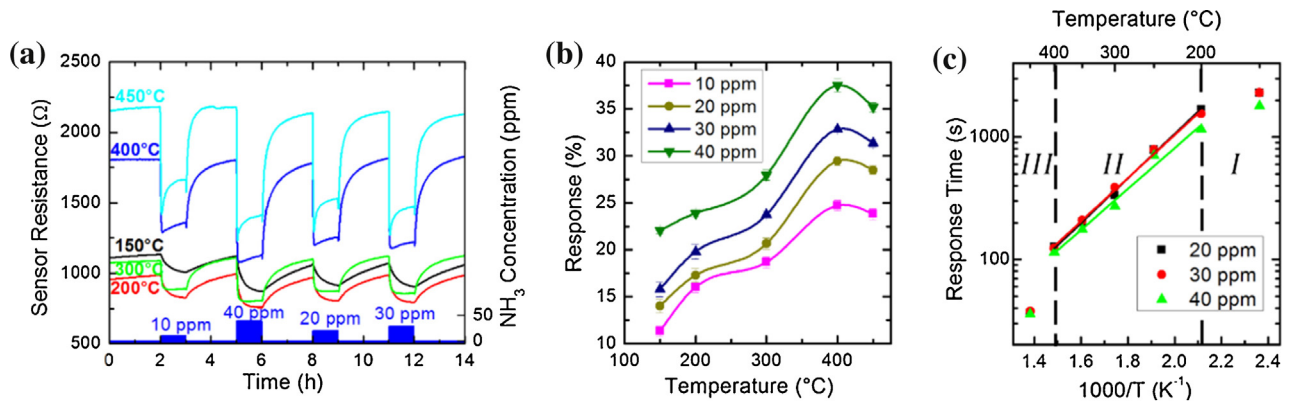


Fig. 4. (a) Evolution of SnO₂ NWs resistance in front of different concentration of ammonia in synthetic air; (b) Response of the test represented in a) in function of temperature; (c) Arrhenius plot of the response time for pulses of 30 ppm of NH₃. Symbols are experimental values and lines are the fitted exponential decay.

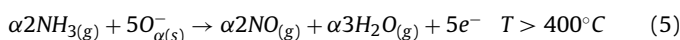
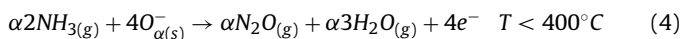
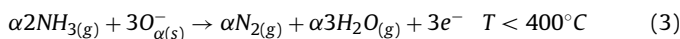
ammonia, expected for an n-type semiconductor gas sensor like tin dioxide, is observed.

The response of the sensor is defined as:

$$\text{Response (\%)} = \frac{R_{\text{air}} - R_{\text{NH}_3}}{R_{\text{air}}} \quad (2)$$

The response as a function of temperature is represented in Fig. 4(b). Localized grown SnO₂ NWs show a response of up to 36% for 40 ppm of NH₃ at 400 °C, temperature at which the response presents a maximum. The response time is defined as the time to evolve from 10% to 90% of the steady state value. A response time as low as 2 min is obtained, again, at 400 °C. An Arrhenius plot of the response time as a function of temperature is represented in Fig. 4(c), where an exponential behavior is deduced.

Three competitive reactions are described in the literature for ammonia oxidation on metal oxide surfaces [18–20]:



where (g) stands for gas, (s) for surface, e⁻ is a conduction electron, α is a coefficient that is equal to 1 for atomic oxygen O⁻ or 2 for molecular oxygen O₂⁻ ionosorbed species and consequently, depends on the working temperature. The three reaction mechanisms are supported by chemisorbed oxygen at the surface of the metal oxide. Our work is focused at temperatures above 200 °C in order to achieve acceptable response time for the gas sensing and, as a consequence, chemisorbed atomic oxygen is the specie that oxidizes ammonia molecules at the surface of the SnO₂ nanowires.

It is well known from catalysis that in a large number of metal oxide catalysts, depending on the temperature one specific reaction is preferred over the others [20,21]. In this direction, the sensing Eqs. (3)–(5) are by no means easy to disentangle. Indeed, these reactions account for oxygen adsorption in the form of the active species and subsequent H stripping from the ammonia molecules till a relevant intermediate containing the NN or NO bond is formed. When this takes place, further H elimination with the concomitant formation of H₂O is carried out. Thus, Eqs. (3)–(5) share more than 70% of their elementary steps. Consequently, in the low temperature regime, i.e., below 400 °C approximately, the Reactions (3) and (4) take place simultaneously.

Reaction (5) dominates at temperatures above 400 °C and surface coverage governs the reaction since higher energy barriers can be surpassed at this temperature, the NO byproduct becomes dominant [20,21]. The nitrogen containing products of the three reactions are therefore oxidized as a function of temperature: the

higher the temperature at which the reaction takes place, the more oxidized is the nitrogen containing product. At the same time, the more oxidized is the nitrogen product also the higher the activation energy, following the relationship $E_{(3)}^{\text{act}} < E_{(4)}^{\text{act}} < E_{(5)}^{\text{act}}$ [20].

The activation energy of the sensor response towards ammonia has been obtained from the response time, which is represented as a function of temperature in Fig. 4(c) in an Arrhenius plot. Three different kinetic regions are defined from the plot according to the experimental measurements: (I) temperatures below 200 °C; (II) between 200 and 400 °C and (III) above 400 °C, each of them with different activation energies.

The main reaction that takes place at lower temperatures (region I) is ammonia oxidation involving molecular oxygen ions, since this species is the main oxygen form at this temperature range, which gives a different activation energy to the one deduced from region II. Activation energy from this region cannot be derived due to the small number of points measured, but a lower slope than region II in the $\tau(1000/kT)$ is traced. The activation energy obtained from Arrhenius plot in region II is $E_{II}^{\text{act}} = 0.35 \pm 0.04\text{eV}$, where ammonia oxidation is supported by atomic oxygen. This process was also found to provide higher activation energy than molecular oxygen in [22]. Therefore, differences in sensing kinetics are explained by the different oxygen species promoting the NH₃ oxidation.

On the other hand, this region comprehends the temperature range where Reactions (3) and (4) can take place on the tin dioxide surface. The exponential behavior of the response time in the Arrhenius plot suggests that the same mechanism takes place over the whole temperature range. As pointed out before, both mentioned reactions can occur simultaneously at these temperatures; both share many elementary steps. The rate determining step O₂ activation is the same and, thus, a unique dependence is found. Furthermore, the ratio between oxygen and ammonia partial pressures ($p_{\text{O}_2}/p_{\text{NH}_3}$) also influences the selectivity towards one of the three reactions. As shown in [20], for $p_{\text{O}_2}/p_{\text{NH}_3} > 10$, the selectivity is lost and N₂ and N₂O are produced in equivalent percentage at temperatures below 400 °C. On the other hand, for low $p_{\text{O}_2}/p_{\text{NH}_3}$ ratios (<0.1), N₂ production is enhanced [18,20], and N₂O production is almost negligible. Consequently, as our experiments are carried out in high $p_{\text{O}_2}/p_{\text{NH}_3}$, sensing mechanism in region II can be considered as the addition of Reactions (3) and (4) taking place in parallel.

The activation energy detailed in this work is lower than in [20] and in a previous work [23], which obtained an activation enthalpy of 0.74 eV (range between 210–260 °C, reaction mixture of 10% of ammonia and 90% of O₂) and 0.5 eV (150–300 °C), respectively. The study of SnO₂ as a catalyst for NH₃ oxidation concluded that the formation of Reaction (3) started at temperatures below 200 °C,

and Reaction (4) takes place for temperatures higher than 200 °C [20]. Furthermore, in previous density functional theory (DFT) studies we concluded that the rate-determining step of NH₃ sensing mechanism in a single SnO₂ monocrystalline nanowire is oxygen adsorption, with an associated activation energy of 0.5 eV, similar to the experimental value obtained in that work [23]. Notice, though that the errors intrinsic to DFT in particular when dealing with the description of O₂ make the DFT value a qualitative estimate. Still, if oxygen adsorption is energetically favored, i.e. oxygen binding energy to the surface increases, then the activation energy of the whole process could be lowered.

A change in tendency of the response time as a function of temperature is observed again at 450 °C in Fig. 4(c), the labelled region III. The variation in transient behavior at 450 °C suggests that a different reaction takes place, which could correspond to Reaction (5), since this latter starts to dominate at about 400 °C. The temperature intervals for NO reaction are in agreement with other works, and are also supported by the transient decay of the sensor resistance at 400 and 450 °C. The initial interaction of ammonia with the metal oxide surface leads to a fast decay of the NWs resistance at these temperatures, followed by a slow increase during the exposure to NH₃. The same behavior has also been observed in metal oxide sensors like WO₃ [19] and In₂O₃/MgO bilayer structure [24] in the characterization of their responses towards ammonia.

Nitric oxide (NO) is easily and readily oxidized to NO₂ at 400 °C [24,25]. SnO₂ NWs are known to respond to less than 100 ppb of NO₂ [26], a value easy to reach during the ammonia and nitric oxide oxidation. Other products generated in the reactions cannot explain the observed increasing resistance. On the one hand, H₂O acts as a reducing agent to tin dioxide, i.e., diminishes the resistance of tin oxide NWs and, consequently, as a product of Reactions (3)–(5), could not provide the increase in resistance. N₂ is inert at the analyzed temperature range and does not affect the conductivity. Furthermore, SnO₂ without additives on its surface requires tens of ppm of N₂O [27] to achieve an observable response. As a result, the only reaction that will give rise to the observed behavior is the oxidation of NO to NO₂, which is the only species able to promote the increasing resistance. Thus, NO₂ attaches to an oxygen vacancy at the SnO₂ surface [28], trapping an electron and therefore the resistance of SnO₂ is increased as a consequence of the reactions:



This fact is confirmed by the reduction of the response for temperatures above 400 °C. Actually, the initial resistance decay towards ammonia at 450 °C is larger than the decay when the sensor is heated at 400 °C. However, the further resistance increase due to NO₂ adsorption reduces the final response (see Fig. 5(d)). Therefore, at this temperature the response of the sensor is explained by Reactions (5)–(7) that take place simultaneously, being (6) and (7) secondary reactions.

The observed low resistance of the NWs network at room temperature is an indicator of the presence of surface defects, i.e., that oxygen vacancies are widely present at the surface of the NWs. Consequently, the gas response is probably lowered partially since chemisorbed oxygen is necessary for the ammonia sensing mechanism, as Reactions (3)–(5) describe.

3.3. SnO₂ NWs sensing mechanisms in humid conditions

3.3.1. SnO₂ NWs interaction towards H₂O

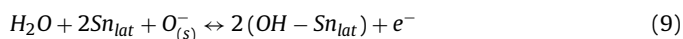
SnO₂ NWs exhibit a reversible response towards different concentration of water vapor at different examined temperatures. Water vapor is expressed as relative humidity in %, i.e., the ratio

of partial water vapor pressure and saturation pressure obtained at room temperature (20 °C). The transient in electrical signal of the sensor towards the presence of water vapor is shown in Fig. 5(a) at an operation temperature of 400 °C. A clear decrease in resistance due to the presence of water vapor is observed, which is reversible as can be seen in the same figure since the baseline value is fully recovered when water vapor is removed from the chamber.

The behavior of the NWs resistance as a function of the relative humidity denotes that water vapor acts as a reducing gas for SnO₂ nanostructures. SnO₂ NWs have been reported as high sensitivity humidity sensor [29]. There are several mechanisms reported in literature for the interaction of H₂O with the tin dioxide surface. Dissociation of water involves the reaction of hydroxyl groups with oxygen atoms from the lattice, providing terminal OH group, and thus, releasing two electrons per molecule to the conduction band according to the following Eqs. [30–32]:



where Sn_{lat} and O_{lat} stands for a tin and oxygen atom in lattice position, respectively, and V_O^- is a doubly ionized oxygen vacancy. Another mechanism related to chemisorbed oxygen at the SnO₂ surface is the competitive reaction of water with pre-adsorbed oxygen ions, which is similar to Eq. (8), but involved oxygen is an atomic chemisorbed specie that releases an electron to the metal oxide [30]:



Eq. (9) is supported by diffuse reflectance infrared Fourier transform (DRIFT) spectroscopy measurements that conclude that only OH terminal groups are formed at the surface of SnO₂ [30]. The authors observed that the concentration of these surface hydroxyl groups increased with oxygen partial pressure, reaching a saturation, and showed that this effect was reversible. Therefore, the concentration of hydroxyl groups which provides the increase in conductivity to the metal oxide is strongly dependent on chemisorbed oxygen. Consequently, when another reducing gas is present, together with H₂O, both will compete for reacting with chemisorbed oxygen atoms.

The resistance as a function of temperature in both dry and humid conditions (30% and 60% of relative humidity) is represented in Fig. 5(b). As can be seen, the sensor resistance decreases at higher concentrations of water vapor. On the other hand, resistance of SnO₂ NWs grows with increasing temperature above 200 °C, showing a U-shaped resistance-temperature curve. The increasing resistance ensures that atomic oxygen is available to react with other species; there is an incomplete coverage of chemisorbed oxygen with hydroxyl groups since otherwise, a decreasing resistance for increasing temperature would be experimentally observed.

3.3.2. Ammonia sensing in humid conditions

Sensing capabilities of tin dioxide nanowires towards ammonia added to water vapor have been investigated at a temperatures of 200, 300 and 400 °C, where mainly atomic oxygen is chemisorbed at the semiconductor's surface. Two different relative humidity levels were employed for each temperature: 30 and 60% for the same sequence of ammonia pulses performed in dry air experiments.

The normalized sensor resistance to the baseline value in synthetic air at 400 °C is represented in Fig. 5(c) for dry and humid conditions towards different concentrations of ammonia. Clearly, the response is reduced in the presence of increasing amounts of water as compared to dry conditions. The sensor resistance does not show the overshoot in resistance observed in the response towards ammonia in dry conditions at 450 °C (see Fig. 5(d) for comparison), suggesting that Reactions (3) and (4) are the main ones that take place in the studied range, and the influence of (5) is here negligible.

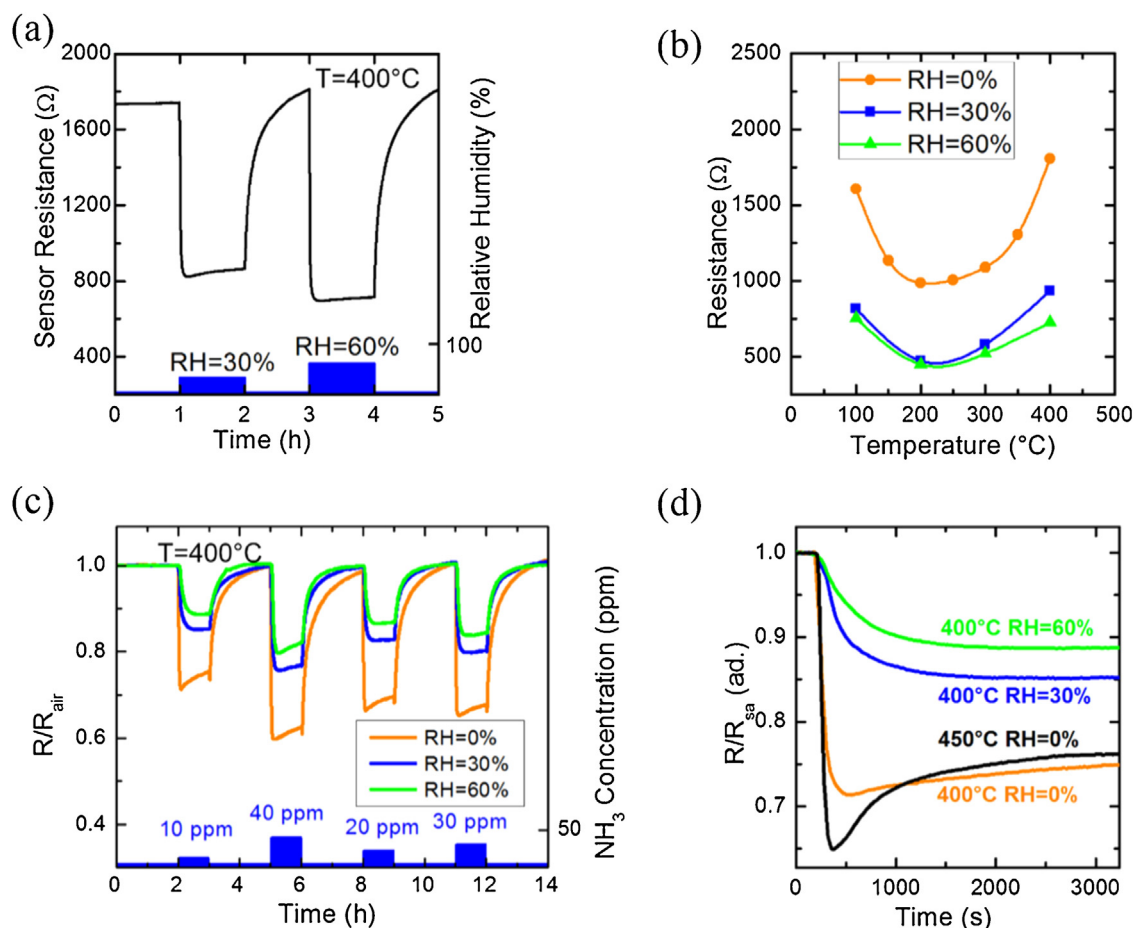


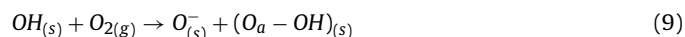
Fig. 5. (a) Electrical response of SnO₂ NWs to different concentrations of water vapor in synthetic air at 400 °C; (b) Resistance of SnO₂ NWs for different humidity levels at different temperature. U-shaped R-T is also obtained in humid conditions due to dissociation of molecular to atomic oxygen at a temperature of 200 °C; (c) Electrical response of SnO₂ NWs in dry, 30% and 60% of relative humidity (RH at room temperature) towards different ammonia pulses in synthetic air. Three tests have been performed by keeping 400 °C constant temperature; (d) Sensor response towards 10 ppm of NH₃ at different conditions. The overshoot in resistance is visible for 450 °C and RH=0% curve.

The reduced response of tin dioxide nanowires against ammonia in the presence of water vapor can be explained by several concurring mechanisms. On the one hand, competitive adsorption between water vapor and ammonia with chemisorbed oxygen takes place. Atomic oxygen and water vapor compete for the same adsorption sites, diminishing the probability of Reactions (3)–(5) in the steady sensing state. Furthermore, 60% of relative humidity at 20 °C corresponds to approximately 14300 ppm of water, a concentration 3 orders of magnitude higher than ammonia in these experiments. Thus, the partial pressure of water is considerably higher than that of ammonia, which leads to much higher coverage of these adsorbed species on the metal oxide surface.

The Arrhenius plot of the response time of the sensor in dry and humid conditions for 30 ppm of ammonia (Fig. 6(a)) shows that the response is slower in humid than in dry conditions, and that the higher the temperature, the higher the difference. Larger response times are a direct consequence of the competitive adsorption between atomic oxygen and water vapor that reduces the probability of oxidizing ammonia and, thus, slows down the reaction. The effect is more pronounced at higher temperatures because under dry conditions the reaction is promoted without any competitive adsorption phenomenon.

At the same time, the activation energies shown in Fig. 6(b), deduced from Fig. 6(a) for different ammonia concentrations and in the different studied relative humidity values, clearly decrease in the presence of water vapor and are essentially independent on the ammonia concentration, within the experimental uncertainty.

As mentioned before, water vapor can dissociate in two hydroxyl species and chemisorb at the surface of tin oxide assisted by a Sn_{1at} and a chemisorbed O⁻_(s) as described in (8). A tentative explanation for the behavior could be derived from the interaction of hydroxyl groups with O₂, as proposed by Epling et al. [33,34] in monocristalline rutile TiO₂ according to:



where O_a stands for an oxygen adatom. This mechanism creates a new path for oxygen dissociation, which can occur even at lower temperatures than oxygen dissociation described in (1), diminishing the activation barrier of oxygen dissociation. According to our previous study of ammonia interaction mechanism, oxygen dissociation is precisely the energy limiting step [23]. Thus, a mechanism similar to (9) could explain the lowering in the activation energy of ammonia sensing in presence of water. There is an extra term of adsorbed oxygen (O_a) which grows with increasing number of OH groups at the surface that can act as H scavenging centers, thus improving the probability of adsorbed ammonia to react with active bases in the intermediate ammonia decomposition steps.

As for endurance, the sensors were operated for 1 month in dry and humid conditions, after which a drift in resistance of 7% from the initial values was observed, but where the resistance change due to the presence of the gases was almost invariant in its value, only about 1%. Fig. 6(d) shows the resistance change at 300 °C and 30% of RH obtained at the 10th and 25th day of operation, and illustrates the repeatability of measurements made with the

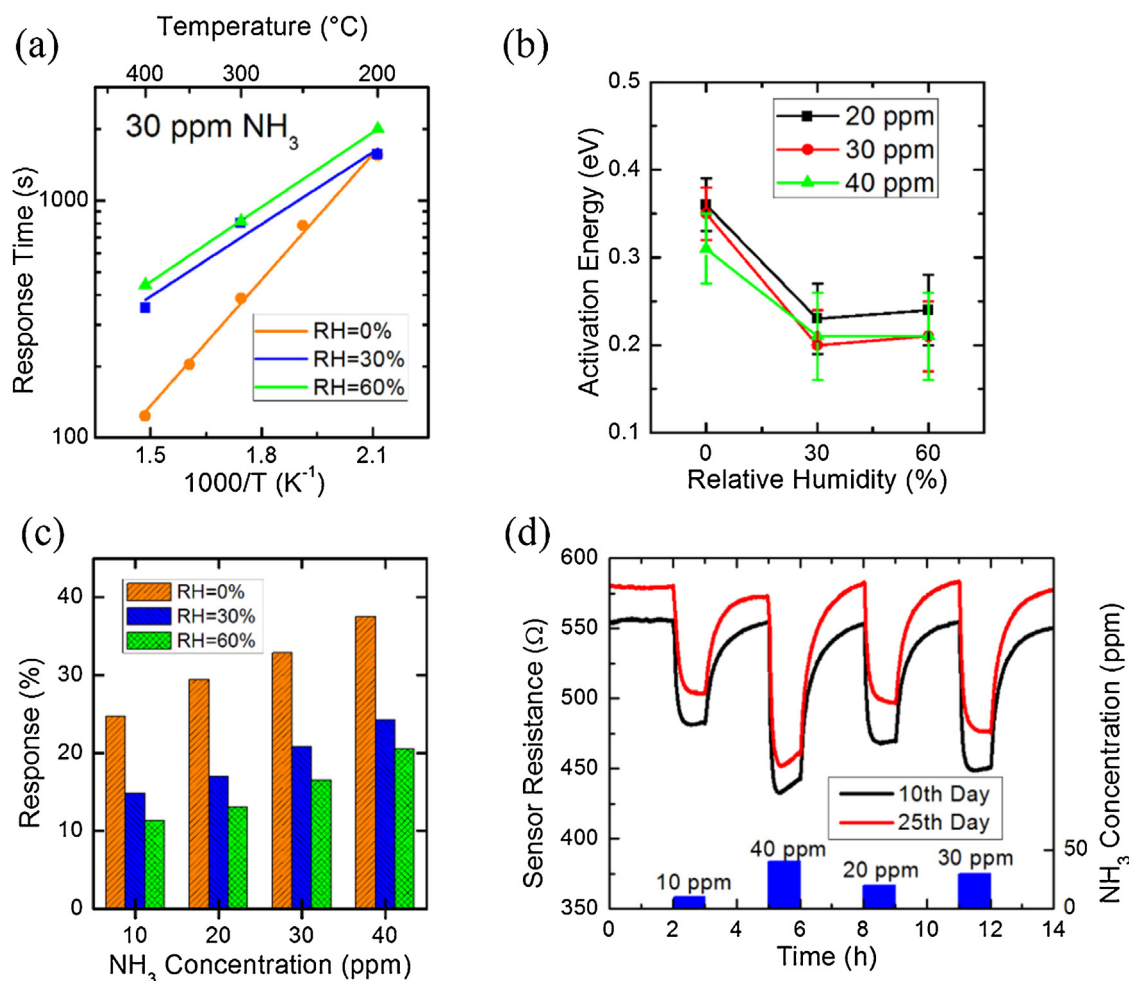


Fig. 6. (a) Response time of sensor of NH₃ pulses of 30 ppm in dry and humid condition, represented in an Arrhenius plot. Symbols are experimental values and lines are the fitted exponential decay; (b) Activation energy obtained from response time for ammonia response in function of relative humidity, for all the concentrations studied; (c) Response in humid condition of SnO₂ NWs against ammonia at 400 °C. The sensor distinguishes the concentration of ammonia in a precision of 30 ppm in realistic operational conditions, where humidity is present; (d) Comparison between the response of the sensor at 300 °C and 30% of RH from 10th and 25th day of measurements. A change of 5% in resistance baseline is obtained.

nanowire-based device. The sensor has shown a good durability, and offers relatively fast response times of 6 minutes in presence of water vapor, and 2 minutes for dry conditions towards 30 ppm of NH₃.

4. Conclusions

The sensing mechanisms of locally grown SnO₂ NWs towards ammonia gas diluted in air, in both dry and humid conditions, have been studied. Different temperature regimes have been identified in the sensor kinetic response. In dry conditions, the promotion of NO as byproduct at high operating temperatures reduces the response of the sensor and provides a maximum ammonia response at 400 °C. When operated in humid conditions, the response of tin dioxide nanostructures is reduced and slowed down by the presence of water vapor. Simultaneously, the activation energy is lowered by moisture, which could be explained through the reaction between O₂ and the OH adsorbed groups, consequence of water decomposition. Finally, the integrated growth of SnO₂ on micromembranes has been demonstrated as a fast, reproducible and low power consuming approach, which gives rise to ammonia sensors with good repeatability, fast response and long term stability.

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Guillem Domènech-Gil was born in Barcelona in 1986. He graduated in physics at University of Barcelona in 2009 and obtained a master degree in nanoscience and nanotechnology at the same faculty in 2014. His research activities started with the growth of metal oxide nanowires for their employment as gas sensors main element towards toxic gases and fabricating nanodevices for monitoring environment. Coauthor at a MRS 2014 and in Eurosensors 2015 with poster and oral presentations. His doctoral studies are focused in enhancing the gas sensing technology through the use of nanostructures with a deeper comprehension of the sensing mechanisms occurring.

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